

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
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Applicant:	Yeo, et al.	Docket No.:	TSM03-0760
Serial No.:	10/803,712	Art Unit:	1795
Filed:	March 18, 2004	Examiner:	Raymond, Brittany L.
For:	Immersion Fluid for Immersion Lithography, and Method of Performing Immersion Lithography		

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

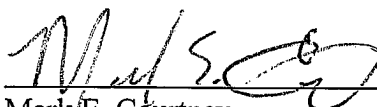
The Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08a that may be considered material to the examination of the above-identified application. Copies of the U.S. Patents and Publications cited are not being submitted.

This Information Disclosure Statement is submitted under 37 C.F.R. §1.97(c) together with a \$180.00 fee under 37 C.F.R. §1.17(p) after the C.F.R. §1.97(b) time period, but before final action or notice of allowance, whichever occurs first.

Respectfully submitted,

October 31, 2008

Date



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